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PATENT
Attorney Docket No. 07553.0017-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Mitsuru ISHIKAWA et al.) Group Art Unit: 1792
Application No.: 09/696,232) Examiner: Olsen, Allan W.
Filed: October 26, 2000) Confirmation No.: 5127
For: ETCHING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed October 11, 2007, the period for response to which extends through January 11, 2008, Applicants amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

Attachment to this Amendment includes one (1) Declaration with an English language translation of Japanese Patent Application No. 11-303422.